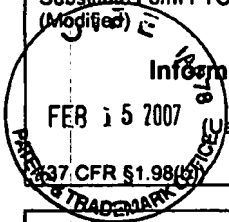


Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05770-156002	Application No. 10/673,307
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Martin W. Rupich et al.	
		Filing Date September 29, 2003	Group Art Unit 1762

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
/FP/	AL	WO 94/17078	08/04/1994	WIPO				
/FP/	AM	EP 0 277 020 A1	08/03/1988	Europe				
	AN							
	AO							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
/FP/	AP	Peizhi, Preparation of $\text{YBa}_2\text{Cu}_3\text{O}_{7-x}$ Superconducting Thin Films by Metalorganic Deposition, Rare Metal Materials and Engineering, Vol. 24, No. 6, pp58-63, 1995.
	AQ	
	AR	
	AS	

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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	